

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: TSUTOMU YAMADA ET AL.

SERIAL NO.: 09/966,692

FILED: September 28, 2001

FOR: METHOD OF ATTACHING LAYER
MATERIAL AND FORMING LAYER
IN PREDETERMINED PATTERN ON
SUBSTRATE USING MASK) Group Art Unit: 2812
)
) Before the Examiner:
) S. Mulpuri
)
)
)#6
Ext. 2 mos.
Response
J. McMillan
4/25/03RESPONSE TO OFFICE ACTIONVia Facsimile to 703-872-9318
Assistant Commissioner for Patents
Washington, D.C. 20231


FAX RECEIVED

APR 17 2003

Sir:

TECHNOLOGY CENTER 2800

In response to the Office Action mailed November 20, 2002, Applicants request reconsideration in view of the following remarks for entry in the above-identified application.

I hereby certify that this correspondence was facsimile transmitted to the United States Patent Office (Fax No. 703-872-9318) on	
April 17, 2003	
(Date of Deposit)	
Patricia A. Jarr	
(Name of Person Making Deposit)	
Signature	Date
	04/17/03

04/25/2003 JNCMILLA 00000004 061130 09966692

01 FC:1252 410.00 CH

YK1-0078
09/966,692